


Form PTO-1449 Modified  List of Patent and Publications Cited by Applicant (Use several sheets if necessary) U.S. Department of Commerce Patent and Trademark Office	Docket No. CFMT-0255	Serial No. 10/074,516
	Applicant Steven Verhaverbeke	
	Filing Date February 13, 2002	Group 1762-1763

U. S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass
<i>SLD</i>	AZ	6,245,158 B1	06/12/01	Verhaverbeke	134	10
<i>SLD</i>	BA	6,261,845 B1	07/17/01	Verhaverbeke, et al.	436	55
<i>4</i>	BB	09/478,034 ^{6,517,636}	01/05/00 ^{2/11/02}	Verhaverbeke	134	002
<i>4</i>	BC	09/564,358 ^{6,372,544}	04/19/00 ^{4/30/02}	DiBello, G.N.	137	068,250
<i>4</i>	BD	09/574,790	05/19/00	Verhaverbeke		
<i>4</i>	BE	09/727,661 ^{6,528,000 6,6717}	12/01/00 ^{6/6/02}	Verhaverbeke, et al.		
<i>4</i>	BF	09/805,348 ^{6,491,763}	03/12/01 ^{12/18/02}	Verhaverbeke, S. et al.		
<i>SLD</i>	BG	09/930,009 ^{US 2002/0104552}	08/13/01 ^{8/8/02}	Bay, et al.	134	018

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Country	Translation YES NO	
<i>SLD</i>	BH	EP 0 233 184 B1	08/26/87	EPO		

EXAMINER


RECEIVED

MAY 13 2002

DATE CONSIDERED

9/23/03

TC 1700

Form PTO-1449 Modified  List of Patent and Publications Cited by Applicant (Use several sheets if necessary) U.S. Department of Commerce Patent and Trademark Office	Docket No. CFMT-0255	Serial No. 10/074,516
	Applicant Steven Verhaverbeke	
	Filing Date February 13, 2002	Group 1762 1763

U. S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass
<i>AW</i>	AP	4,917,123	04/17/90	McConnell, et al.	134	95
	AQ	4,984,597	01/15/91	McConnell, et al.	134	95
	AR	5,383,484	01/24/95	Thomas, et al.	134	184
	AS	5,569,330	10/29/96	Schild, et al.	131	1
	AT	5,571,337	11/05/96	Mohindra, et al.	134	25.4
	AU	5,972,123	10/26/99	Verhaverbeke	134	3
	AV	6,032,682	03/07/00	Verhaverbeke	134	1.3
	AW	6,135,522	10/17/00	Verhaverbeke, et al.	134	26
	AX	6,143,087	11/07/00	Walter	134	1
<i>AW</i>	AY	6,165,912	12/26/00	McConnell, et al.	438	758

FOREIGN PATENT DOCUMENTS

[illegible]

Form PTO-1449 Modified <div style="border: 1px solid black; border-radius: 50%; padding: 5px; display: inline-block; text-align: center;"> OIPE MAY 09 2002 U.S. DEPT. OF COMMERCE PATENT & TRADEMARK OFFICE </div>		Docket No. CFMT-0255		Serial No. 10/074,516	
List of Patent and Publications Cited by Applicant (Use several sheets if necessary)		Applicant Steven Verhaverbeke			
U.S. Department of Commerce Patent and Trademark Office		Filing Date February 13, 2002		Group 1765	

U. S. PATENT DOCUMENTS						
Examiner Initial		Document No.	Date	Name	Class	Subclass
<i>AW</i>	AF	4,577,650	03/25/86	McConnell	134	59
	AG	4,633,893	01/06/87	McConnell, et al.	134	95
	AH	4,738,272	04/19/88	McConnell	134	59
	AI	4,740,249	04/26/88	McConnell	134	25.4
	AJ	4,778,532	10/18/88	McConnell, et al.	134	10
	AK	4,795,497	01/03/89	McConnell, et al.	134	18
	AL	4,856,272	08/15/89	Putman, et al.	60	39.02
	AM	4,856,544	08/15/89	McConnell, et al.	134	95
	AN	4,899,767	02/13/90	McConnell, et al.	134	56R
<i>AW</i>	AO	4,911,761	03/27/90	McConnell, et al.	134	11

FOREIGN PATENT DOCUMENTS						
Examiner Initial		Document No.	Date	Country	Translation YES NO	

RECEIVED
 MAY 13 2002
 TC 1700

EXAMINER <i>AW</i>	DATE CONSIDERED <i>9/23/03</i>
--------------------	--------------------------------

Form PTO-1449 Modified

Docket No.
CFMT-0255Serial No.
10/074,516Applicant
Steven VerhaverbekeList of Patent and Publications
Cited by Applicant
(Use several sheets if necessary)U.S. Department of Commerce
Patent and Trademark OfficeFiling Date
February 13, 2002Group
~~1762~~ (176)

U. S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass
<i>Lee</i>	35	4,206,541	06/10/80	Marciniec	29	611
<i>Lee</i>	36	5,851,303	12/22/98	Hwang, et al.	134	3
<i>Lee</i>	37	5,949,126	09/07/99	Dawson, et al.	257	513
<i>Lee</i>	38	6,083,840	06/04/00	Mravic, et al.	438	693
<i>Lee</i>	39	09/209,101 6,495,099	12/10/98 12/17/02	Verhaverbke, et al.	422	028
<i>Lee</i>	40	09/253,157	02/19/99	Verhaverbeke, et al.		

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Country	Translation YES NO	


EXAMINER

Alla Dan

DATE CONSIDERED

9/23/03

RECEIVED
SEP 13 2002
TC 1700

Form PTO-1449 Modified		Docket No. CFMT-0255	Serial No. 10/074,516
 List of Patent and Publications Cited by Applicant (Use several sheets if necessary) U.S. Department of Commerce Patent and Trademark Office		Applicant Steven Verhaverbeke	
		Filing Date February 13, 2002	Group 1762 1763
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
<i>See</i>	AA	Burkman, D.C. et al., "Aqueous Cleaning Processes", Chapter 3, Handbook of Semiconductor Wafer Cleaning Technology , (edited by Werner Kern, Published by Noyes Publication Parkridge, New Jersey, 1993, 111-151	
<i> </i>	AB	Horiki, H. et al., "Wet Etch Cleaning", <i>Ultraclean Technology Handbook</i> , Ultra Pure Water, Volume 1, Chapter 3, 805-819	
<i>-</i>	AC	Werner Kern, et al., <i>Thin Film Processes</i> , "Chemical Etching", 1978, 401-496	
<i>-</i>	AD	Werner Kern, "Overview and Evolution of Semiconductor Wafer Contamination and Cleaning Technology", Chapter 1 , 3-67	
<i>See</i>	AE	Verhaverbeke, S. et al., "Scientific rinsing and drying on macro and microscale", <i>Semiconductor Pure Water and Chemicals Conference</i> , Balazs, M.J. (Ed.), Santa Clara, Ca., March 4-7, 1996, 14 pages	
EXAMINER <i>Alta Obo</i>		DATE CONSIDERED <i>9/23/03</i>	

RECEIVED

MAY 13 2002

TC 1700